

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q86826

Mitsushi ITANO, et al.

Appln. No.: 10/527,202

Confirmation No.: 2273

Group Art Unit: 1792

Filed: March 10, 2005

Examiner: Tabassom Taddayyon ESLAMI

For: ETCHING SOLUTION AND ETCHING METHOD

**AMENDMENT UNDER 37 C.F.R. § 1.114(c)**

**MAIL STOP RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Final Office Action of November 8, 2007. An RCE and Petition for Extension of Time (for one (1) month) extending the time for replying from February 8, 2008 to March 8, 2008, are submitted concurrently herewith. Please amend the above-identified application as follows.

**TABLE OF CONTENTS**

AMENDMENTS TO THE CLAIMS.....	2
REMARKS.....	7